TFW

PTO/SB/21 (02-04)
Approved for use through 07/31/2006, OMB 0651-0031
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

Linder the Panenwork Reduction Act of 199	5. no person	U.S. Pater	at and Trademark Office; U.S. DEPARTMENT OF COMMERC on of information unless it displays a valid OMB control number			
C C C C C C C C C C C C C C C C C C C		Application Number	10/786,410			
TRANSMITTAL		Filing Date	February 24, 2004			
FORM		First Named Inventor	Dan MAYDAN, et al.			
2 2001 Clo be used for all correspondence after initia	l filing)	Art Unit	1763			
2 3 2004	ZIII. C. T		Unknown			
S. J. S.	4	Attorney Docket Number	006915 P10			
FAN-Ma Total Number of Pages in This Submission						
	ENC	LOSURES (Check all that	t apply)			
Fee Transmittal Form Fee Attached Amendment/Reply After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request X Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53		Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Addre Terminal Disclaimer Request for Refund CD, Number of CD(s)	After Allowance communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Repty Brief) Proprietary Information Status Letter Other Enclosure(s) (please Identify below):			
	TURE C	OF APPLICANT, ATTORNE	EY, OR AGENT			
Firm or Individual name Robert M. Wall Signature	lace	Reg. No. 29	9,119			
Date 11–18–2004	un					
		ATE OF TRANSMISSION	WAN INC			
		CATE OF TRANSMISSION				
			deposited with the United States Postal Service with ents, P.O. Box 1450, Alexandria, VA 22313-1450 on			
Typed or printed name Shelly 1	Hart					
Signature	1/2	1 Knot	Date 11-18-2004			

This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S C 122 and 37 CFR 1.14. This collection is estimated to 2 hours to complete, including gathering, preparing, and submitting the completed application form-to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patient and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450, Department of Commissioner for Patients, P.O. Box 1450, Alexandria, VA 22313-1450.



PATENT

Attorney Docket No. 006915 P10 RW Ref. No. APM/009-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Dan MAYDAN, et al.) Group Art Unit: 1763
Entitled: FABRICATION OF SILICON-ON- INSULATOR STRUCTURE USING PLASMA IMMERSION ION IMPLANTATION) Examiner: Unknown))
Serial No.: 10/786,410)
Filing Date: February 24, 2004)

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(b)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached hereto is Form PTO-1449 listing documents believed relevant to the subject application. It is respectfully requested that these documents be made of record and an initialed copy of each form be returned to the undersigned.

No representation is made that more pertinent material is not available or should not be considered by the Examiner. It is expected that the Patent and Trademark Office will independently conduct a complete search of appropriate art. Furthermore, no admission is being made that these documents are prior art, and applicant reserves the right to challenge any such consideration.

It is believed that this disclosure complies with the requirements of 37 CFR 1.56, 1.97, and 1.98, and the Manual of Patent Examining Procedures, section 609 and 707.05. If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each foreign patent document and/or non-patent literature is enclosed. Some of the documents may have markings on them. No significance is meant to be attached to the markings. These documents are not necessarily analogous art.

Respectfully submitted,

Robert M. Wallace

Registration No. 29,119 Attorney for Applicants Customer No. 000044843

Robert M. Wallace Patent Attorney 2112 Eastman Avenue, Suite 102 Ventura, CA 93003 (805) 644-4035 FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 006915 P10 Serial No.: 10/786,410

Applicant(s): Dan MAYDAN, et al.

Filing Date: 02-24-2004

NOV 2 3 2004

LIST OF PRIOR ART CITED BY APPLICANT

(Use several sheets if necessary)

Group: 1763

U. S. PATENTS

U. S. IAIENIS									
Initials	Patent No	Issue Date	Name	Class	Subclass	Filing Date			
	US-4,510,672	04-16-1985	YAKURA ET AL.	21	225	04-16-85			
	US-4,914,500	04-03-1990	LIU ET AL.	357	67	04-03-90			
	US-5,136,969	08-11-92	CHAPMAN	118	305	01-25-91			
	US-5,840,589	11-24-1998	WARNER, JR. ET AL.	437	128	06-06-95			
	US-5,918,140	06-29-199	WICKBOLDT ET AL.	438	535	06-16-97			
	US-6,190,979 B1	02-20-2001	RADENS ET AL.	438	301	06-12-99			
	US-6,312,999 B1	11-06-2001	CHIVUKULA ET AL.	438	303	03-29-01			
	US-6,475,859 B1	11-05-2002	TEWS ET AL.	438	243	06-13-00			
	US-6,500,741 B2	12-31-2002	BUCHANAN ET AL.	438	558	03-28-02			
	US-6,506,653 B1	01-14-2003	FURUKAWA ET AL.	438	305	03-13-00			
	US-6,566,192	05-20-2003	LIN	438	243	02-07-02			
	US 2002/0197806 A1	12-26-202	FURUKAWA ET AL.	438	305	08-16-02			
	US 2003/0134469 A1	07-17-03	HORZEL ET AL.	438	249	01-27-03			
	US 2004/0077157 A1	04-22-04	CHAKRAVARTHI ET AL.	438	510	10-02-03			

Initials Other Documents (Title, Author, Date, Pages, Etc., if known)

Huff, H. and Zeitzoff, Peter M., "An analytical look at vertical transistor structures", Solid State Technology, pp. 59-72, August 2004.

Examiner's Signature:

Date Considered:

Initial if reference was considered, whether or not citation with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).